Oral presentation | Joint Session K "Wide bandgap oxide semiconductor materials and devices" | 21.1 Joint Session K "Wide bandgap oxide semiconductor materials and devices"

[13p-D419-1~16]21.1 Joint Session K "Wide bandgap oxide semiconductor materials and devices"

Takashi Yasuda(Ishinomaki Senshu Univ.), Takumi Ikenoue(Kyoto Univ.)

Fri. Mar 13, 2020 1:45 PM - 6:15 PM D419 (11-419)

 \triangle : Presentation by Applicant for JSAP Young Scientists Presentation Award

▲ : English Presentation

▼: Both of Above

No Mark: None of Above

1:45 PM - 2:15 PM

[13p-D419-1][The 10th Compound Semiconductor Electronics
Achievement Award Speech] Growth of GaAs-based,
ZnSe-based, and oxide semiconductors with evolutional technologies

OShizuo Fujita¹ (1.Kyoto Univ.) Keywords:Isamu Akasaki Award